

PTO/SB/08B (10-01)

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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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Sheet 3 of **Complete if Known**

Application Number	09/920,891
Filing Date	August 2, 2001
First Named Inventor	Kwan, Michael, et. al.
Art Unit	1763
Examiner Name	Kackar, Ram N.
Attorney Docket Number	A4231/T34410

U.S. PATENT DOCUMENTS

Examiner	Cite No. ¹	Document Number Number Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
RK	AA	US-4,690,746	09/01/87	McInerney et al.	
DH	AB	US-4,872,947	10/10/89	Wang et al.	
RK	AC	US-4,892,753	01/09/90	Wang et al.	
RK	AD	US-4,960,488	10/02/90	Law et al.	
RK	AE	US-5,000,113	03/19/91	Wang et al.	
RK	AF	US-5,089,442	02/18/92	Olmer	
RK	AG	US-5,156,881	10/20/92	Okano et al.	
RK	AH	US-5,271,972	12/21/93	Kwok et al.	
RK	AI	US-5,275,977	01/04/94	Otsubo et al.	
RK	AJ	US-5,279,865	01/18/94	Chebi et al.	
RK	AK	US-5,302,233	04/12/94	Kim et al.	
RK	AL	US-5,319,247	06/07/94	Matsuura	
RK	AM	US-5,362,526	11/08/94	Wang et al.	
RK	AN	US-5,416,048	05/16/95	Blalock et al.	
RK	AO	US-5,468,342	11/21/95	Nulty et al.	
RK	AP	US-5,571,576	11/05/96	Qian et al.	
RK	AQ	US-5,599,740	02/04/97	Jang et al.	
RK	AR	US-5,624,582	4/29/97	Cain	
RK	AS	US-5,679,606	10/21/97	Wang et al.	
RK	AT	US-5,719,085	02/17/98	Moon et al.	
RK	AU	US-5,850,105	12/15/98	Dawson et al.	
RK	AV	US-5,858,876	1/2/99	Chew	
RK	AW	US-5,872,052	02/16/99	Iyer	
RK	AX	US-5,915,190	6/22/99	Pirkle	
RK	AY	US-5,937,323	8/10/99	Orczyk et al.	
RK	AZ	US-5,872,058	02/16/99	Van Cleemput et al.	
RK	BA	US-5,953,635	09/14/99	Andideh	
RK	BB	US-5,968,610	10/19/99	Liu et al.	
RK	BC	US-5,990,000	11/23/99	Hong et al.	
RK	BD	US-6,030,881	02/29/00	Papasouliotis et al.	
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RK	BF	US-6,039,851	03/21/00	Iyer	
RK	BG	US-6,059,643	5/9/00	Hu et al.	
RK	BH	US-6,136,685	10/24/00	Narwanker et al.	
RK	BI	US-6,167,834	01/02/01	Wang et al.	

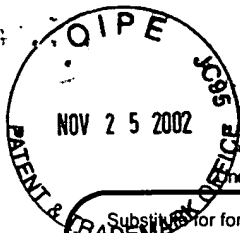
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Sheet 4

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U.S. PATENT DOCUMENTS

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Ru	BJ	US-6,170,428	01/09/01	Redeker et al.	
Ru	BK	US-6,182,602	02/06/01	Redeker et al.	
Ru	BL	US-6,189,483	02/20/01	Ishikawa et al.	
Ru	BM	US-6,335,288	01/01/02	Kwan et al.	
Ru	BN	US-6,395,150	05/28/02	Van Cleemput et al.	
Ru	BO	09/400,338	filed 09/21/99	Xia et al.	

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)				
Ru	BP	JP	2-58836	A	02/28/1990			<input type="checkbox"/>
Ru	BQ	JP	7-161703	A	06/23/95			<input type="checkbox"/>

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
Ru	BR	ABRAHAM, "Reactive Facet Tapering of Plasma Oxide for Multilevel Interconnect Applications," VMIC Conference, pp. 115-121 (1987)	
Ru	BS	LEE et al., "Dielectric Planarization Techniques for Narrow Pitch Multilevel Interconnects," VMIC Conference, pp. 85-92 (1987)	
B	BT	QIAN et al., "High Density Plasma Deposition and Deep Submicron Gap Fill with Low Dielectric Constant SiOF Films," DUMIC Conference, pp. 50-56, held in California (1995)	

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